

U	+	Inventor	Document	Issue	P	Title	Current	Current XR	Retrieval	S	C	P	+	-	+	-	+	-	Image Doc.	P
1	<input type="checkbox"/>	Uda, Yoshimi	US 8921207	20030	3	Substrate having fine line, electron source a	313/495	313/285		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 892120	<input type="checkbox"/>
2	<input type="checkbox"/>	Shimoda, Tai	US 6372608	20020	5	Separating method, method for transferring	438/455	257/E21.56		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 637260	<input type="checkbox"/>
3	<input type="checkbox"/>	Yamazaki, Sh	US 6376333	20020	2	Method of manufacturing flexible display wit	438/458	257/E21.13		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 637633	<input type="checkbox"/>
4	<input type="checkbox"/>	Ott, George e	US 2004021	20041	1	Integrated inductor in semiconductor manufa	257/531			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200402	<input type="checkbox"/>
5	<input type="checkbox"/>	Wilkie, W. Ke	US 2004004	20040	1	Piezoelectric composite apparatus and a mat	29/25.3	29/611		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200400	<input type="checkbox"/>
6	<input type="checkbox"/>	Uda, Yoshimi	US 2004002	20040	3	Substrate having fine line, electron source a	313/495			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200400	<input type="checkbox"/>
7	<input type="checkbox"/>	Cai, Wei et al	US 2003021	20031	3	Multi-set rectangular copper hairpin winding	310/208			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200302	<input type="checkbox"/>
8	<input type="checkbox"/>	Ott, George e	US 2003010	20030	1	Integrated inductor in semiconductor manufa	438/531	257/531		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200301	<input type="checkbox"/>
9	<input type="checkbox"/>	WILKIE, W. K	US 2003005	20030	1	PIEZOELECTRIC MACRO-FIBER COMPOSITE	29/25.3	29/830		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200300	<input type="checkbox"/>
10	<input type="checkbox"/>	Kaku, Mariko	US 2003003	20030	1	Semiconductor integrated circuit device	257/458	257/E23.02		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 200300	<input type="checkbox"/>

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